

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No.	Application No.:
	SUNIP833	09/851,554
	Applicant:	
	SOKOLOV et al.	
Filing Date	05/08/01	Group
		2176 2122

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-Class	Filing Date

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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
MY	1	Lindholm et al, "The Java™ Virtual Machine Specification", (Sept, 1996), Sun Microsystems, Inc., Chapters 1-10 (173 pp.)
Examiner	Date Considered	
Michael Yigdal	6/2/04	

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



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U.S. Patent Documents

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	A1						

Foreign Patent or Published Foreign Patent Application

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							Yes	No
MY	B1	WO 9848354A	10/29/98	WIPO	—	—	X	
MY	B2	WO 9910811	03/04/99	WIPO	—	—	X	

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
MY	C1	Agesen <i>et al.</i> , "Garbage Collection and Local Variable Type-Precision Liveness in Java™ Virtual Machines, Association for Computing Machinery, New York, Vol. 33, No. 5, May 19, 1998, pp. 269-279
MY	C2	Barabash <i>et al.</i> , "Mostly Accurate Stack Scanning", Proceedings of the Java/Sup Tm/ Virtual Machine Research and Technology Symposium, Monterey, California, April 23 and 24, 2001, pp. 153-170
Examiner <i>Michael Yigdel</i>		Date Considered 6/2/04

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